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INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO FORM 1449	Atty. Docket No. 10191/2304	Serial No. To Be Assigned
	Applicant(s) HAUER et al.	
	Filing Date Herewith	Group To Be Assigned

U. S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
T.B	5,955,668*	Sep. 21, 1999	SAUNDERS et al.			

* Copy of reference is not enclosed because reference is cited in Search Report (copy provided by the International Searching Authority).

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
						YES	NO
T.B	197 46 127*	May 12, 1999	Germany				

* Copy of reference is not enclosed because reference is cited in Search Report (copy provided by the International Searching Authority).

OTHER DOCUMENTS

EXAMINER'S INITIALS		AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
T.B		Lutz et al., <i>A Precision Yaw Rate Sensor in Silicon Micromachining</i> , SAE Technical Paper, 980267.*
T.B		Funk et al., <i>Surface-Micromachining of Resonant Silicon Structures</i> , The 8th International Conference on Solid-State Sensors and Actuators, Eurosensors IX, Stockholm, Sweden, 25-29 June 1995, pp. 50-52.**

* Copy of reference is not enclosed because reference is cited in Search Report (copy provided by the International Searching Authority).

** Described in the Specification.

EXAMINER Jamillo Bellamy	DATE CONSIDERED 4/29/03
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	